



Patent
Attorney's Docket No. 027260-295

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) **MAIL STOP AF**
Kazuya KAMON)
Application No.: 09/320,946) Group Art Unit: 1756
Filed: May 26, 1999) Examiner: S. Mohamedulla
For: PHOTOMASK, FABRICATION)
METHOD OF PHOTOMASK, AND)
FABRICATION METHOD OF)
SEMICONDUCTOR INTEGRATED)
CIRCUIT) Confirmation No.: 5658

AMENDMENT UNDER 37 C.F.R. §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: November 10, 2003

Sir:

This Amendment responds to the Office dated August 13, 2003 (Paper No. 23).

Please amend the above-identified application as follows:

11/12/2003 HDEMESS1 00000095 09320946

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